

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Vyyoda et al.)
Serial No.: 09/918,853) Examiner: Toledo, Fernando L.
Filed: July 30, 2001) Group Art Unit: 2895
For: Process for Fabricating a Dielectric)
Film Using Plasma Oxidation)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendment and remarks in response to the PTO
Communication mailed March 24, 2010.